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		Application Number	10/528,265		
		Confirmation Number	2280		
		Application Filing Date	March 17, 2005		
		First Named Inventor	Hideomi KOINUMA		
		Art Unit	1792		
		Examiner Name	Jeffrie R. Lund		
Sheet	1	of	1	Attorney Docket Number	052267

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		Number	Kind Code <sup>2</sup> <i>(if known)</i>		
		US			
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FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Translation <sup>6</sup>
		Country Code <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>5</sup> <i>(if known)</i>			

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.	Translation <sup>6</sup>
	1	European Search Report dated December 19, 2008 issued in corresponding Application No. 03797681.8	
	2	C.J. BOWLER and R.D. GOULD, "A sequential masking system for the deposition of multilayer thin-film structures" JOURNAL OF VACUUM SCIENCE TECHNOLOGY, 1987, pages 114-115, XP001308318 Woodbury, NY, USA	

Examiner Signature	Date Considered
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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